


<b>Search Notes</b>  	<b>Application/Control No.</b>  10567028	<b>Applicant(s)/Patent Under Reexamination</b>  PICKLES ET AL.
	<b>Examiner</b>  Jennifer Dieterle	<b>Art Unit</b>  1759

SEARCHED			
Class	Subclass	Date	Examiner
204	400, 415, 416, 418	4/23/09	JMD
Updated above		5/25/10	JMD
204	400,409,433,412,406,408,410,411,415,416,421,422,434, 280	12/12/10	JMD
205		12/12/10	JMD
updated above		4/20/11	JMD
204	294	4/20/11	JMD

SEARCH NOTES		
Search Notes	Date	Examiner
EAST, Google, Inventor	4/23/09	JMD
Spoke with Kaj Olsen concerning applicant's amendments and verified art is applicable to make rejection final	10/12/09	JMD
Consulted with Kaj Olsen, also consulted with Alen Olsen concerning etching processes, both indicated that my prior art Shiomi is applicable.	5/25/10	JMD
EAST, Google, Inventor, consulted with Kaj Olsen	12/12/10	JMD
consulted with Kaj Olsen, EAST, Inventor	4/20/11	JMD

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner
	interference text search of claim language	12/12/10	JMD
205	775,782.5,786.5,787.5,793,794.5	12/12/10	JMD
204	400,409,433,412,406,408,410,411,415,416,421,422,434, 280	12/12/10	JMD
Updated above		4/20/11	JMD
204	294	4/20/11	JMD

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